Application/Control No.	Applicant(s)/Patent under Reexamination		
10/642,264	HUANG ET AL.		
Examiner	Art Unit		
James D. Stein	2874		

	SEARCHED				
Class	Subclass	Date	Examiner		
385	142	2/3/2005	<b>105</b> JDS		
385	143	2/3/2005	JDS JPS		
385	144	2/3/2005	JDS JA		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
files	removed	2/3/2005	JDS JDS	
	I	<del></del>		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
See attached EAST search history	2/3/2005	JDS JDS		